



Docket No. 740819

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Yoshiyuki TANI

Serial No. 09/874,367

Filed: June 6, 2001

For: PHOTOMASK MAKING METHOD
AND ALIGNMENT METHOD

)

) Group Art Unit: 1756

) Examiner: Christopher G. Young

) Confirmation No. 2951

) Date: August 29, 2003

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[37 CFR 1.8(a)]

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AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed April 1, 2003, please consider the following amendments and remarks in connection with the above-identified application.

09/08/2003 CSIAS1 00000002 192380 09874367

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